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| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. | • |
|--|---------------|----------------------|---------------------|------------------|---|
| 09/118,010 | 07/17/1998 | SHUNPEI YAMAZAKI | 0756-1838 | 8550 | |
| 75 | 90 05/21/2004 | | EXAM | INER | |
| ROBINSON INTELLECTUAL PROPERTY LAW OFFICE | | | GUERRERO, MARIA F | | |
| PMB 955 21010 SOUTHBANK STREET POTOMAC FALLS, VA 20165 | | | ART UNIT | PAPER NUMBER | • |
| | | | 2822 | | |
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DATE MAILED: 05/21/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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|--|---|---|--|--|--|
| | Application No. | Applicant(s) | | | |
| | 09/118,010 | YAMAZAKI ET AL. | | | |
| Office Action Summary | Examiner | Art Unit | | | |
| | Maria Guerrero | 2822 | | | |
| The MAILING DATE of this communication Period for Reply | appears on the cover sheet | with the correspondence address | | | |
| A SHORTENED STATUTORY PERIOD FOR RE THE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CFI after SIX (6) MONTHS from the mailing date of this communication - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory pe - Failure to reply within the set or extended period for reply will, by st Any reply received by the Office later than three months after the m earned patent term adjustment. See 37 CFR 1.704(b). | N. R 1.136(a). In no event, however, may reply within the statutory minimum of t riod will apply and will expire SIX (6) M atute, cause the application to become | a reply be timely filed hirty (30) days will be considered timely. ONTHS from the mailing date of this communication. ABANDONED (35 U.S.C. § 133). | | | |
| Status | | | | | |
| 1) Responsive to communication(s) filed on 2 | 9_March 2004. | | | | |
| 2a) ☐ This action is FINAL . 2b) ☑ This action is non-final. | | | | | |
| 3) Since this application is in condition for allo | wance except for formal ma | atters, prosecution as to the merits is | | | |
| closed in accordance with the practice und | er <i>Ex par</i> te <i>Quayle</i> , 1935 C | .D. 11, 453 O.G. 213. | | | |
| Disposition of Claims | | | | | |
| 4) Claim(s) <u>1-8 and 11-73</u> is/are pending in th | e application. | | | | |
| 4a) Of the above claim(s) is/are with | | | | | |
| 5) Claim(s) is/are allowed. | • | | | | |
| 6)⊠ Claim(s) <u>1-8 and 11-73</u> is/are rejected. | | | | | |
| 7) Claim(s) is/are objected to. | | | | | |
| 8) Claim(s) are subject to restriction an | d/or election requirement. | | | | |
| Application Papers | | | | | |
| 9)☐ The specification is objected to by the Exam | niner. | | | | |
| 10) The drawing(s) filed on is/are: a) | | o by the Examiner. | | | |
| Applicant may not request that any objection to | | - | | | |
| Replacement drawing sheet(s) including the cor | - · · · · · · · · · · · · · · · · · · · | · | | | |
| 11) ☐ The oath or declaration is objected to by the | | • | | | |
| Priority under 35 U.S.C. § 119 | | | | | |
| 12)⊠ Acknowledgment is made of a claim for fore a) ☐ All b) ☐ Some * c) ☐ None of: | eign priority under 35 U.S.C. | § 119(a)-(d) or (f). | | | |
| 1. Certified copies of the priority docum | ents have been received. | | | | |
| 2. Certified copies of the priority docum | ents have been received in | Application No. <u>08/962,840</u> . | | | |
| 3. Copies of the certified copies of the p | priority documents have bee | en received in this National Stage | | | |
| application from the International Bur | reau (PCT Rule 17.2(a)). | | | | |
| * See the attached detailed Office action for a | list of the certified copies no | ot received. | | | |
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| | | | | | |
| Attachment(s) | | | | | |
| Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) | 4) 🔲 Interview Paper N | v Summary (PTO-413) o(s)/Mail Date | | | |
| Information Disclosure Statement(s) (PTO-1449 or PTO/SB. Paper No(s)/Mail Date <u>57</u> . | | f Informal Patent Application (PTO-152) | | | |
| S. Patent and Trademark Office PTOL-326 (Rev. 1-04) Offic | e Action Summary | Part of Paper No./Mail Date 59 | | | |

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DETAILED ACTION

1. This Office Action is responsive to the Request for continued examination filed March 29, 2003.

Claims 9-10 are canceled.

Claims 1-8 and 11-73 are pending.

Continued Examination Under 37 CFR 1.114

2. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on March 29, 2003 has been entered.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-8 and 11-73 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tamahiko Nishiki et al. (JP 63-279228) (cited by Applicant) in view of Takenouchi et al. (U.S. 5,427,961).

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4. Tamahiko Nishiki et al. discloses a semiconductor device comprising a first substrate, a TFT having pixel electrodes with source and drain regions, a second substrate, a gate insulating film, and a semiconductor film (amorphous silicon (including microcrystalline silicon)) (Fig. 1(A)-6). Tamahiko Nishiki et al. teaches an insulating film (polyimide) having a flat surface provided on the first substrate to planarize the surface (Fig. 1(A)-6, pages 8-15).

Tamahiko Nishiki et al. fails to disclose the substrate being a resinous substrate such as polyethylene terephlate, polyethylene napthtalate, polyethylene sulfite and polyimide as claimed. Tamahiko Nishiki et al. fails to show the resinous material consisting of: methyl ester of acrylic acid, ethyl ester of acrylic acid, butyl ester of acrylic acid and 2-ethyhexyl ester of acrylic acid as claimed. However, this is known in the art as evidenced Takenouchi et al.

Takenouchi et al. discloses a semiconductor device having a resinous substrate, the resinous substrate made of polyester (e.g., PET (polyethylene terephlate)), polyimide, fluoroplastic, PES (polyethylene sulfane) (col. 3, lines 49-55). Takenouchi et al. also teaches a resinous layer provided on the resinous substrate including an acrylic resin (e.g. methyl acrylate ester, ethyl acrylate ester, butyl acrylate ester, and 2-ethyhexyl acrylate ester (col. 3, lines 55-60). In addition, Takenouchi et al. discloses providing the film on the substrate with the purpose of leveling the initial surface irregularities (col. 4, lines 10-15).

Therefore, it would have been obvious to a person of ordinary skill in the art at the time the invention was made to modify Tamahiko Nishiki et al. reference by including

the resinous substrate taught by Takenouchi et al. in order to reduce cost and to obtain a device easily handled having a larger field of application and free from oligomeros (Takenouchi et al., col. 1, lines 15-25, col. 3, lines 20-25).

Furthermore, the limitation "obtained by crystallizing amorphous silicon" is a product-by process limitation and the patentability of a product does not depend on its method of production. If the product in the product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process." In re Thorpe, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985) (citations omitted).

Response to Arguments

5. Applicant's arguments with respect to claims 1-8 and 11-73 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

- 6. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Takafuji et al. (U.S. 4,746,628) is cited as evidence to show that in a broad interpretation the amorphous silicon includes the microcrystalline silicon (Takafuji et al., col. 3, lines 5-10).
- 7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Maria Guerrero whose telephone number is 571-272-1837.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on 571-272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Maria Guerrero Primary Examiner May 17, 2004

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